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A

Attorney Docket No. 0756-1896

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hisashi OHTANI et al.

Serial No. 09/197,767

Filed: November 23, 1998

For: SEMICONDUCTOR DEVICE AND
PROCESS FOR PRODUCING THE
SAME

) Group Art Unit: 2814

) Examiner: P. Cao

) CERTIFICATE OF MAILING

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Alexandria, VA 22313-1450, on November 15,
2004.

) Adeline M. Stanger

RESPONSE

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The Official Action mailed July 14, 2004, has been received and its contents carefully noted. Filed concurrently herewith is a *Request for One Month Extension of Time*, which extends the shortened statutory period for response to November 14, 2003. Accordingly, the Applicants respectfully submit that this response is being timely filed.

The Applicants note with appreciation the consideration of the Information Disclosure Statements filed on March 16, 2000, June 14, 2000, October 19, 2000, January 31, 2001, October 31, 2001, February 28, 2002, June 13, 2002, May 2, 2003, November 10, 2003, and April 19, 2004.

Claims 1-5, 16, 22-27, 40 and 46-74 are pending in the present application, of which claims 1-5 and 47-50 are independent. For the reasons set forth in detail below, all claims are believed to be in condition for allowance. Favorable reconsideration is requested.

Paragraph 1 of the Official Action rejects claims 1, 2, 5, 16, 22-27, 40, 47, 48, 51, 52, 55, 56, 59, 60, 63, 64, 67, 68, 71 and 72 under 35 U.S.C. § 112, first paragraph, asserting that the claims fail to comply with the written description requirement.

PC
12/13/04